



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto et al.

Art Unit : 2814

Serial No. : 09/903,339

Examiner : Theresa T. Doan

Filed : July 10, 2001

Title : METHOD FOR PRODUCING INSULATED GATE THIN FILM  
SEMICONDUCTOR DEVICE

**MAIL STOP AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF NOVEMBER 3, 2004

Please amend the above-identified application as follows:

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 4.